

Notice of References Cited

Application/Control No.

10/702,564

Applicant(s)/Patent Under
Reexamination
BISCHEL ET AL.

Examiner

Alessandro V. Amari

Art Unit

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* A	Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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NON-PATENT DOCUMENTS

* U	Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	Sang-shin Lee et al. "Variable Optical Attenuator based on a cutoff modulator with Tapered Waveguides in polymers" Journal Lightwave Technology, vol. 17, no. 12, (December 1999), pp. 2556-61.

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.

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